

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Atsushi YAGISHITA, et al.) Group Art Unit: *Not Yet Assigned*
)
Div. of Application No.: 09/609,109) Examiner: *Not Yet Assigned*
)
Filed: Herewith)
)
For: SEMICONDUCTOR DEVICE WITH)
A DISPOSABLE GATE AND)
METHOD OF MANUFACTURING)
THE SAME (AS AMENDED)
HEREIN)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PRELIMINARY AMENDMENT

Prior to the examination of the above application, please amend this application as follows:

IN THE TITLE:

On page 1, please replace the title at lines 2-3 with the following title:

SEMICONDUCTOR DEVICE WITH A DISPOSABLE GATE AND METHOD OF
MANUFACTURING THE SAME

REMARKS

This application is a divisional, under 37 C.F.R. § 1.53(b), of U.S. Patent Application No. 09/609,109, presently allowed. In this Preliminary Amendment, Applicants have amended the title. In accordance with the requirements of 37 C.F.R. § 1.121(c)(1), Applicants provide a

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